

Centurion™ C1-S

One Cylinder Semi Automatic Gas Cabinet





SEMI-GAS® supplies SEMI S2 certified, production-ready ultra high purity gas source systems, distribution systems and control technology to leaders in the Semiconductor industry and related high-tech fields. Built to address the most rigorous precision and purity demands of these specialized applications, SEMI-GAS® solutions are globally renowned for their premier levels of safety, quality, and performance.

DESIGN STANDARDS

- Conforms to SEMI S2 Standards
- ♦ UL Labeled
- Conforms to Uniform Building and Fire Codes
- ♦ Upholds Sample Validation Testing Standards
- ♦ Helium Leak Tested to 1x10⁻⁹ atm-cm³/sec
- Equipped with GigaGuard[™] ESS Controller

FEATURES

- Safely Dispenses Hazardous Process Gases
- Automatic Shutdown in the event of an Alarm Trip
- Utilizes Manual Purge Process
- Monitors Flow, Pressure, Exhaust and Fire Sensors
- Intuitive Operating Interface and Control
- ♦ LED Lights Provide Constant System Status
- Continuously Monitors System Conditions for Alarms
- ◆ Remote Outputs for System Status and/or Shutdown

ENGINEERING DATA

- Dimensions: 83"T X 15"W X 23"D
- ♦ Exhaust Duct: 6" Diameter
- Window Open Duct Flow: 350 SCFM
- ♦ Voltage: 100 to 250 VAC, 1 Phase
- Frequency: 50 to 60 Hz

MATERIALS OF CONSTRUCTION

- Welded 11 Ga Steel Enclosure
- ♦ Self-Closing and Self-Latching Door
- Self-Closing and Self-Latching Window
- Heavy Cast Aluminum Cylinder Brackets
- Polycarbonate Face Shield
- Durable, Corrosion Proof, Non-Skid Floor Mat
- UL Approved Fire Sprinkler
- 1/4" Thick Safety Glass Window





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SAFETY FEATURES

- Door Switch Monitor for applications that require extra security and/or limited access (optional)
- Rate of Rise Heat Detector for flammable gas applications (optional)
- Hazardous Gas Detector for all hazardous, toxic, and/or flammable gas applications (required for silane, consult local codes for all other gases)
- Purge Gas Bleed Valve for manifolds and piping systems with large internal volumes or line lengths (optional)
- Controller Z-Purge Kit for systems installed in Class 1
 Division 2 hazardous locations, as well as applications for silane and silane mixtures greater than 1.37% (required for silane)
- Dual Cylinder Restraints for applications that require additional cylinder security or are located in seismic zones (required for specific seismic areas)
- Shutboy Software Upgrade to accommodate Shutboy valve shutters for automatically closing the gas cylinder valve during emergency situations (optional)

ORDERING INFORMATION

Example: One Cylinder Semi Automatic Gas Cabinet



Product



Configuration





Control



Manifold



Operation







Purge

Option

Ontion

Product

C = Centurion[™] Gas Cabinet

Configuration

- 1 = 1 Cylinder
- 2 = 2 Cylinder
- **3** = 3 Cylinder

Control

- **M** = Manual
- S = Semi Automatic
- A = Fully Automatic

Process Manifold

- 2 = 2-Valve (for inert gases)
- **3** = 3-Valve (for inert gases)
- **5** = 5-Valve (for toxic, flammable, and reactive gases)

Operation

- X = Autoswitchover
- N = Independent Processes

Purge

- P = Purge
- O = No Purge

Option

- I = Individual Process Cabinets
- **S** = System Upgrades for Silane
- *All Centurion™ Gas Cabinets can be customized to meet unique specifications. Contact your SEMI-GAS® sales rep for details.

